

LIST OF PRIOR ART CITED BY APPLICANT  
(Filed on January 12, 2005)

DT15 Rec'd PCT/PTO 12 JAN 2005

Docket No. GK-OEH-191/500814.20093

Applicant(s): Guenter HOLLEMANN, Martin LEITNER and Jan SYMANOWSKI

Application No. (Int'l Appln No. PCT/DE2003/002359 10JUL03) Group:

Filed:

Examiner:

## U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
AK	AA	4,725,787	02/16/1998	Chandra			
	AB	4,896,119	01/23/1990	Williamson, et al.			
	AC	5,867,324	02/02/1999	Kmetec, et al.			
	AD	5,907,570	05/25/1999	Nighan, et al.			
AK	AE	6,122,097	09/19/2000	Weston, et al.			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES NO
AK	AL	1 308 384	02/28/1973	Great Britain			
	AM	0 609 978	08/10/1994	European			
	AN	WO 96/16484	05/30/1996	WIPO			
	AO	199 27 918	12/21/2000	Germany			Abstract only
	AP	199 58 566	06/07/2001	Germany			Abstract only
	AQ	2 357 369	06/20/2001	Great Britain			
	AR	100 43 269	04/04/2002	Germany			Abstract only
AK	AS	100 63 976	07/04/2002	Germany			Abstract only
	AT						

## OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AK	AX	R. Iffländer, Solid state Lasers for Materials Processing, Springer Series in Optical Sciences, Springer Verlag, Berlin (2001)
	AY	
	AZ	

Examiner:

H. Rodger

Date:

4-10-07

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**SUPPLEMENTA'**  
**LIST OF PRIOR ART CITED BY APPLICANT**  
(Filed on September 23, , 2005)

PTO-1449 Equivalent

Docket No. GK-OEH-191/500814.20093

Applicant(s): Guenter HOLLEMANN, Martin LEITNER and Jan SYMANOWSKI

Application No. 10/521,088 (Int'l Appln No. PCT/DE2003/002359 10JUL03) Group:

Filed: *9-23-05* Examiner:

**U.S. PATENT DOCUMENTS**

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
	AA	4,725,787	02/16/1998	Chandra			
	AB	4,896,119	01/23/1990	Williamson, et al.			
	AC	5,867,324	02/02/1999	Kmetec, et al.			
	AD	5,907,570	05/25/1999	Nighan, et al.			
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	AM	0-609-978	08/10/1994	European				
	AN	WO-96/16484	05/30/1996	WIPO				
	AO	199-27-918	12/21/2000	Germany			Abstract only	
	AP	199-58-566	06/07/2001	Germany			Abstract only	
	AQ	2-357-369	06/20/2001	Great Britain				
	AR	100-43-269	04/04/2002	Germany			Abstract only	
	AS	100-63-976	07/04/2002	Germany			Abstract only	
	AT							

**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

<i>ARC</i>	AX	R. Iffländer, Solid state Lasers for Materials Processing, Springer Series In Optical Sciences, Springer Verlag, Berlin (2001) pages 28-32
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	AZ	

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Date: *4-10-07*

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NOTE: Strikethrough documents were submitted on January 12, 2005